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To the Director of the U.S. Patent and Ti



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inal documents or copy thereof.



Name of conveying party(ies):

Kyu Young HWANG Ho Young LEE Du-Sik PARK

Name and Address of receiving party(ies):

SAMSUNG ELECTRONICS CO., LTD. 416, Maetan-dong, Yeongtong-gu Suwon-si, Gyeonggi-do Republic of Korea

	Republic of Korea				
3.	Nature of conveyance: X				
4.	Application number(s) or patent number(s): This document is being filed together with a new application: (a) The execution date(s) of the application is/are: (b) The title is: BLOCK-BASED IMAGE RESTORATION SYSTEM AND METHOD OR This document is being filed after filing of the application: (a) Patent Application No(s). 12/035,583, filed February 22, 2008; or (b) Patent No(s)., issued.				
5.	Name and address of party to whom correspondence concerning document should be mailed: STEIN, MCEWEN & BUI, LLP Our Docket: 0040.1068 Attention: Michael D. Stein 1400 Eye St., N.W., Suite 300 Washington, D.C. 20005				
6.	Total number of applications and patents involved:1				
7.	Total fee (37 CFR 3.41)(\$ 40.00 per Patent or Application in Assignment) Enclosed Authorized to be charged to Deposit Account No. 503333.				
8.	Deposit Account No. 503333: (Any underpayment is authorized to be charged to this Deposit Account) (Attach duplicate copy of this page if paying by deposit account)				
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PATENT REEL: 020589 FRAME: 0018

Attorney Docket No.:

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IN CONSIDERATION of the sum of One Dollar (\$1.00), and of other good and valuable consideration paid to the undersigned inventor(s) (hereinafter, "ASSIGNOR") by

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BLOCK-BASED IMAGE RESTORATION SYS	STEM AND METHOD		
relating to International Patent Application PCT/JP_was executed on even date herewith or, if not so ex		hich application for Letters Patent of the United States	
(a) executed on ;	(Insert date of exec	ution of application, if not concurrent)	
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Application No. Not yet assigned;	hereby authorized to	hereby authorized to insert in (b) the specified data, when known.	
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IN WITNESS WHEREOF, the undersigned inver (Typed Name & Signature of Inventor(s))	ntor(s) has (have) affixed his/h (Date)	ner/their signature(s). (Typed Name & Signature of Witness(es))	
1) Kyu Young HWANG	February 11, 2008		
2) He Young LEE	February 11, 2008	,	
3) Du-Sik PARK	February 11, 2008		
4)			
5)			

PATENT REEL: 020589 FRAME: 0019

RECORDED: 02/26/2008